

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re the Application of:

Fumio FUTAMI et al.

Serial No. 10/809,841

Group Art Unit: 2828

Confirmation No. 8145

Filed: March 26, 2004

Examiner: Phillip Nguyen

For: MULTI-WAVELENGTH LIGHT SOURCE APPARATUS

**AMENDMENT**

Commissioner for Patents  
PO Box 1450  
Alexandria, VA 22313-1450

Sir:

This is in response to the Office Action mailed March 13, 2007, and having a period for response set to expire on June 13, 2007.

The following amendments and remarks are respectfully submitted. Reconsideration of the claims is respectfully requested.